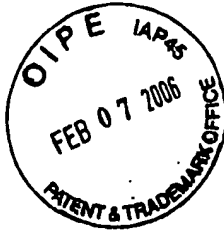


Patent



Docket No. 1232-5324

21W
AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): OHSAKI

EXPEDITED PROCEDURE

Serial No.: 10/797,218

Art Unit: 2851

Filed: March 9, 2004

Examiner: H. Nguyen

For: EXPOSURE METHOD

AMENDMENT AND REQUEST FOR RECONSIDERATION
(37 CFR § 1.116)

Approved for
entry
2/13/06
HN

Mail Stop - AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir,

Kindly amend the above-identified application in response to the final Office

Action dated November 8, 2005.